

# A two-frequency acousto-optic modulator driver to improve the beam pointing stability during intensity ramps

B. Fröhlich, T. Lahaye, B. Kaltenhäuser, H. Kübler, S. Müller, T. Koch, M. Fattori and T. Pfau  
5. Physikalisches Institut Universität Stuttgart, Pfaffenwaldring 57, 70569 Stuttgart, Germany  
(Dated: November 26, 2024)

We report on a scheme to improve the pointing stability of the first order beam diffracted by an acousto-optic modulator (AOM). Due to thermal effects inside the crystal, the angular position of the beam can change by as much as 1 mrad when the radio-frequency power in the AOM is reduced to decrease the first order beam intensity. This is done for example to perform forced evaporative cooling in ultracold atom experiments using far-off-resonant optical traps. We solve this problem by driving the AOM with two radio-frequencies  $f_1$  and  $f_2$ . The power of  $f_2$  is adjusted relative to the power of  $f_1$  to keep the total power constant. Using this, the beam displacement is decreased by a factor of twenty. The method is simple to implement in existing experimental setups, without any modification of the optics.

## I. INTRODUCTION

An important application of acousto-optic modulators (AOMs) is the control of laser beam intensities. The power of the sound wave traveling inside the acousto-optic crystal determines the amount of light that is diffracted out of an incoming laser beam. However, thermal effects lead to a displacement of the diffracted beams when the power of the radio-frequency driving the AOM is changed. The position stability is a critical parameter in many applications using AOMs, especially for dipole traps formed by strongly focused, far off-resonant laser beams [1]. Such traps are playing a major role in atomic physics nowadays, as they allow for the realization of new experiments, for example the Bose-Einstein condensation (BEC) of atomic species that cannot be condensed in magnetic traps such as cesium or chromium [2], or the all-optical generation of a BEC [3]. Particularly in crossed optical dipole traps, where two beams have to be overlapped on a  $10 \mu\text{m}$  scale, a small change of the beam position can have a dramatic effect on the trap characteristics (frequency and depth), thus causing severe problems [4]. One way to circumvent them, is to use a single-mode optical fibre after the AOM, but this cannot be done for high power lasers, such as  $\text{CO}_2$  or ytterbium fibre lasers. In this paper we report on a simple scheme, adaptable to any AOM, which strongly reduces the beam displacement. The method is based on driving the AOM with two different radio-frequencies  $f_1$  and  $f_2$ , and adjusting their relative powers  $P_1$  and  $P_2$  so that the total RF power  $P = P_1 + P_2$  in the AOM is kept constant [5]. This article is organized as follows: After describing the experimental setup with which we measure the beam displacement, we present our measurements for AOMs in the  $1 \mu\text{m}$  and the  $10 \mu\text{m}$  wavelength range. In an appendix we show the details of the electronic circuit we use to adjust  $P_2$  relative to  $P_1$  with a single control voltage.

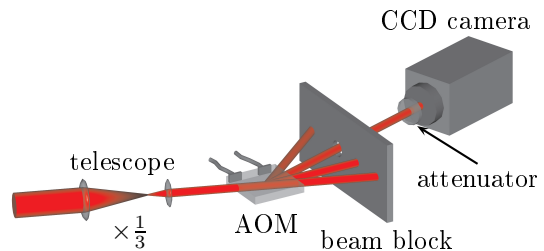


FIG. 1: (Color online) Setup for measuring the beam displacement of the AOM using a  $\text{TeO}_2$  crystal. The size of the laser beam is reduced with a telescope before it enters the AOM. A beam block after the AOM stops all light except the used beam, which is attenuated and monitored with a CCD camera. The distance between the AOM and the camera is 1.4 m.

## II. EXPERIMENTAL SETUP

We test the two-frequency method with two AOM models that use different acousto-optic crystals to modulate the light. The setup for measuring the beam displacement of the first AOM using a tellurium dioxide ( $\text{TeO}_2$ ) crystal (Crystal Technology 3110-199) is shown in figure 1. We use an ytterbium fiber laser (IPG, model YLR-20-1064-LP-SF) at 1064 nm, with 10 W output power. The  $1/e^2$  beam radius is reduced with a telescope from initially 2.1 mm to 0.7 mm before going through the AOM. After the AOM a beam block stops all light except the used beam, which is attenuated and monitored with a CCD camera. We fit the images with a 2D-gaussian and record the peak position of the beam profile. The setup for the second AOM using a germanium (Ge) crystal (IntraAction Corp. AGM-406B1) is slightly different. We use a  $\text{CO}_2$  laser (Coherent GEM100L) at  $10.6 \mu\text{m}$ , with 21 W of power going through the AOM. At a distance of about 3 m we measure the beam profile in one dimension with a movable pinhole in front of a power meter. We fit the profile with a gaussian and record the peak position.

Figure 2 shows the modified AOM driver one has to use for the two-frequency method. To control laser in-

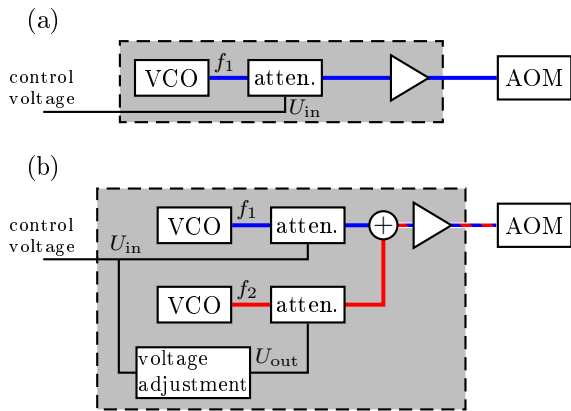


FIG. 2: (Color online) (a) Normal setup for driving an AOM with variable RF power. A voltage controlled oscillator (VCO) generates the radio-frequency  $f_1$  (blue line), which is attenuated to a value given by the control voltage  $U_{in}$ . The signal is then amplified before going to the AOM. (b) For the two-frequency AOM driver we add an extra VCO and attenuator. The additional VCO generates the second RF signal  $f_2$  (red line), whose power is adjusted relative to  $f_1$  to keep the total power in the AOM constant. This adjustment is done by modifying the control voltage  $U_{in}$  with an electronic circuit (shown in detail in the appendix). For the TeO<sub>2</sub> AOM we use the following Mini-Circuits components: VCO POS-150, attenuator PAS-3, combiner ZMSC-2-1, amplifier ZHL-1-2W.

tensities with an AOM, one has to change the RF power driving it. This can be done by attenuating a RF signal coming from a voltage controlled oscillator (VCO) before amplifying it to its final value (figure 2 (a)). The amount of light that is diffracted out of the incoming beam is then determined by the control voltage  $U_{in}$ . For the two-frequency driver we add a second VCO and attenuator (figure 2 (b)) with frequency  $f_2$ . The two frequencies  $f_1$  and  $f_2$  are chosen close enough in order to be well within the bandwidth of the AOM [6], but far enough to give a sufficient separation of the two first order beams. We use  $f_1 = 99$  MHz (resp. 30 MHz) and  $f_2 = 123$  MHz (resp. 50 MHz) for the TeO<sub>2</sub> (resp. Ge) AOM. The power of the frequency  $f_2$  generated by the second VCO is adjusted relative to the power of  $f_1$  in order to keep the total power in the AOM constant. To do this with a single control voltage,  $U_{in}$  is modified by an electronic circuit (see appendix) before it is applied to the second attenuator. We adjust the transfer function  $U_{out}(U_{in})$  of the circuit to have a constant total RF power after the signals are added *and amplified*, the latter condition being crucial to take into account the amplifier saturation.

Laser light going through an AOM driven by two frequencies is diffracted in many different beams as can be seen in figure 3. The image was taken with the TeO<sub>2</sub> AOM at about equal power of both RF signals. Besides the zeroth order beam, the first order of both frequencies, as well as second and even third order beams, which correspond to multiple absorption and stimulated emission of phonons [7], can be seen. For measuring the beam

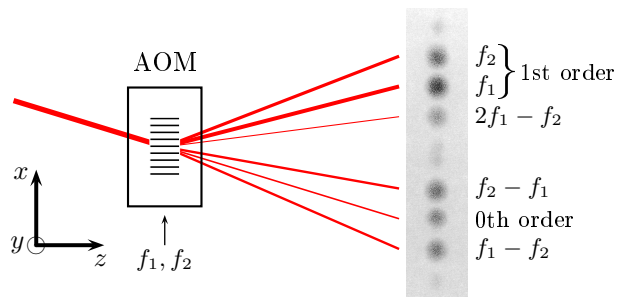


FIG. 3: (Color online) Schematic of the AOM driven by two frequencies. The image shows a picture of the laser beam diffracted by the TeO<sub>2</sub> AOM. On the right hand side of the image the frequency shifts corresponding to the diffracted light are indicated ( $f_1 = 99$  MHz,  $f_2 = 123$  MHz).

displacement we optimize the angle between the acoustic wave and the incident laser beam to have the maximum power in the first order of  $f_1$ . With full power at this frequency and none at  $f_2$ , we achieve diffraction efficiencies up to 90%.

### III. MEASUREMENTS

With the setups described above we measure the position of the first order beam of  $f_1$  at different RF powers for the two AOMs, with and without the second frequency. In figure 4 we plot the angular movement as a function of the laser power in the first order beam. Figure 4 (a) shows the displacement perpendicular to the plane of diffraction  $y$  for the TeO<sub>2</sub> AOM. The displacement in the plane of diffraction  $x$  (not shown in the figure) has the same dependence as perpendicular to it, but is smaller by a factor of three. Adding the second frequency keeps the beam position almost constant (below 0.03 mrad), whereas without, a beam displacement of up to 0.6 mrad occurs. A big improvement is also evident for the Ge AOM (figure 4 (b)), the angular movement is reduced by a factor of ten. The fact that we are not able to compensate the displacement as well as with the TeO<sub>2</sub> AOM is due to the higher RF power the AOM is driven with. For maximum diffraction efficiency the Ge AOM needs 30 W RF power, whereas the TeO<sub>2</sub> AOM needs only 2 W. Another TeO<sub>2</sub> AOM that we tested (A-A Opto-Electronics deflector, model MTS80-A3-1064Ac) uses a sheer mode acoustic wave and needs only 0.5 W RF power for maximum diffraction efficiency. Its beam movement is significantly smaller than for the other AOMs, only up to 0.1 mrad, but still larger than with the two-frequency method [8].

To supplement those steady state measurements, we have also checked for the TeO<sub>2</sub> crystal that the suppression of the beam movement remains good, when the RF power is *dynamically* ramped down over a timescale of a few seconds, as is done for forced evaporative cooling of ultracold atoms.

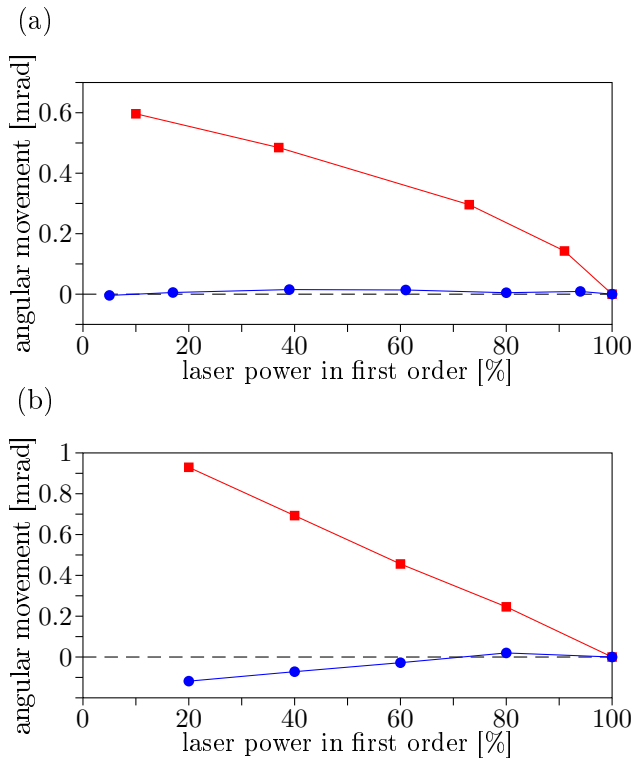


FIG. 4: (Color online) (a) Measured angular movement of the first order beam perpendicular to the plane of diffraction ( $y$ ) with (blue circles) and without the second frequency (red squares) for the TeO<sub>2</sub> AOM. The movement is plotted as a function of the relative laser power in the first order with respect to its maximum value. (b) Same measurement for the Ge AOM, measured in the diffraction plane  $x$ .

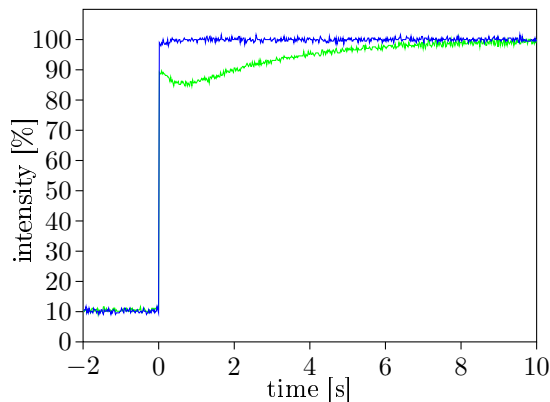


FIG. 5: (Color online) Time dependence of the laser intensity when switching the RF power rapidly. Without the second frequency (green) it takes nearly 10 seconds for the intensity to stabilize to its steady state value. With the second frequency (blue) there is only a very small transient effect in the first second.

The two-frequency method helps also to stabilize the laser power  $P$  in the first order when switching the RF power rapidly as can be seen in figure 5, which shows the time dependence of  $P(t)$  for the TeO<sub>2</sub> AOM. Without the second frequency it takes about 10 seconds until the steady state value is reached, when switching the laser power abruptly from 10 to 100%. The beam displacement takes place over the same time scale. Only a very small transient effect in the first second after switching can be seen, when using the two-frequency method.

In conclusion we have demonstrated a simple method to improve the pointing stability of a beam diffracted by an AOM when the intensity is ramped down. The salient advantage of this technique lies in the fact that only the RF driver has to be modified, without any modifications of the optics.

### Acknowledgments

We thank C. S. Adams for useful discussions and W. Möhrle for the design of the digital control box. We gratefully acknowledge the support of the German Science Foundation (DFG) (SFB/TR 21) and the Landestiftung Baden-Württemberg. T. L. acknowledges support from the European Marie Curie Grant MEIF-CT-2006-038959.

### APPENDIX: VOLTAGE ADJUSTMENT CIRCUIT

In this appendix we present a simple way to realize the voltage adjustment needed for the two-frequency method (figure 2 (b)). The electronic circuit shown in figure 6 (a) modifies the control voltage  $U_{\text{in}}$ , so that the total RF power stays constant in the AOM. We measured the required calibration curve  $U_{\text{out}}$  as a function of  $U_{\text{in}}$ , which the circuit approximates by a stepwise linear function. To do this, we use an inverting amplifier whose gain at low voltages is given by  $-\frac{R_{11}+R_{12}}{R_1+R_2}$ . Parallel to  $R_1$  and  $R_2$  are other resistors ( $R_3, R_4, \dots$ ) in series with Zener diodes. If  $U_{\text{in}}$  is larger than the Zener voltage of one of the diodes it gets conducting and the gain is increased. For example if  $4.3 \text{ V} \leq U_{\text{in}} \leq 6.3 \text{ V}$  the gain is increased to  $-\frac{(R_{11}+R_{12})}{(R_1+R_2) \parallel (R_3+R_4)}$ . Thus, each time  $U_{\text{in}}$  exceeds a Zener voltage of one of the diodes the gain increases. The amplified voltage  $U'$  is then inverted to  $U''$  before in the last step the voltage  $U_{\text{off}}$  is added. The potentiometer  $R_{16}$  allows for an extra gain in the last step. We use large potentiometers for all resistors to have a big flexibility for the transfer function. In figure 6 (b) the measured transfer function is plotted. With this we are able to keep the total RF power after amplification constant within 10%, which is enough to strongly reduce the beam displacement. For the setup using the Ge AOM we use a more complex control box, which digitizes  $U_{\text{in}}$  with an analog-to-digital converter and then generates the out-

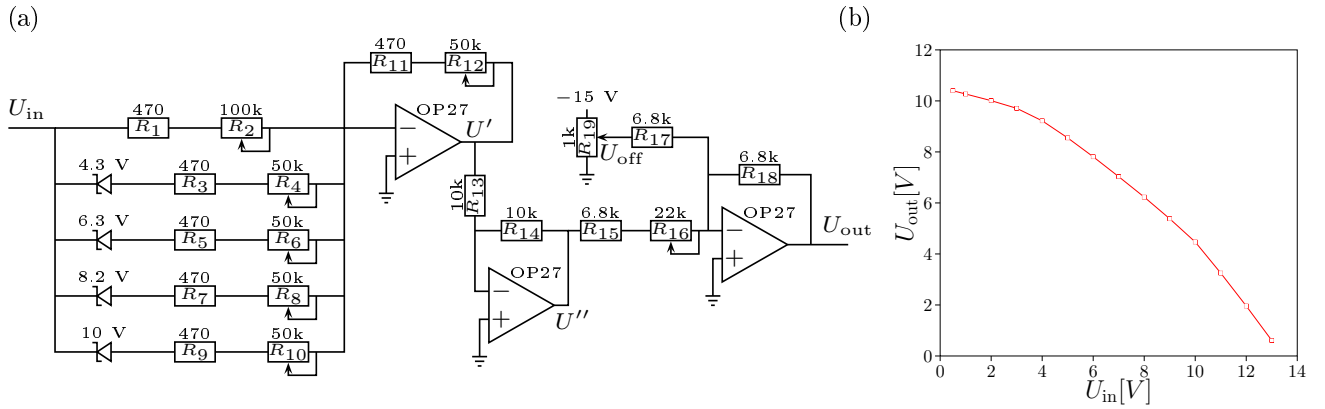


FIG. 6: (Color online) (a) Schematic of the electronic circuit for adjusting the control voltage. The gain of the first inverting amplifier depends on the voltage  $U_{in}$  due to the Zener diodes. The amplified voltage is inverted again before a variable offset  $U_{off}$  is added in the last step. (b) Measured transfer function of the circuit.

put voltage  $U_{out}$  according to a conversion table written in an EPROM.

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